Supporting Information for

Self-Assembly 3D Porous Crumpled MXene Spheres as Efficient Gas and Pressure Sensing Material for Transient All-MXene Sensors

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Supplementary Figures



Fig. S1 SEM images of a-b PS spheres, c MS-2-5, d MS-2-10, and e MS-2-20. f TEM image of MS-2-10

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Fig. S2 a XPS survey spectra and **b** O 1s spectra of 2D MXene, MS-2-5, MS-2-10, and MS-2-20



Fig. S3 a-e The production process of PVA substrate with "MXENE" pattern. **f** The resistance measurement at both ends of "M". **g-k** The production process of PVA substrate with "JLU" pattern. **l** The resistance measurement at both ends of "U"

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Fig. S4 a The resistance measurement of MXene electrode before sticking tape. **b** The image of MXene electrode with tape. **c** The image of MXene electrode after removing the tape. **d** The resistance measurement of MXene electrode after removing the tape



Fig. S5 Schematic diagram of the dynamic test system of gas sensing performance



Fig. S6 TDynamic response-recovery curve of sensors based on **a** MS-2-5, **b** MS-2-10, and **c** MS-2-20 upon exposure to 100 ppm of ethanol, acetone, ethanol, toluene and ammonia



Fig. S7 Dynamic response-recovery curve of sensors based on MS-2-10 upon exposure to 5 ppm NO_2 at relative humidity of 0%, 30%, 60%, and 90%

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Fig. S9 Real-time resistance curve of pressure sensor on 22.22 kPa load with different duration

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Fig. S10 Real-time resistance curve of pressure sensor on 22.22 kPa load at different intervals



Fig. S11 a The degradation process of the transient NO₂ sensor in 30% H_2O_2 for 30 min. **b** The degradation process of the transient pressure sensor in 10% H_2O_2 for 1 h